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Docket No.: 245768US0TTC

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ATTORNEYS AT LAW

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313 ATTN: LICENSING AND REVIEW

RE: Application Serial No.: 10/717,628

Applicants: Masami ENDA, et al. Filing Date: November 21, 2003

For: SYSTEM AND METHOD FOR CHEMICAL

DECONTAMINATION OF RADIOACTIVE

MATERIAL

Group Art Unit: 1746

Examiner:

SÌR:

Attached hereto for filing are the following papers:

Supplemental Statement Required Under Section 152 of the Atomic Energy Act (3pp., executed)

Our check in the amount of **0** is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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